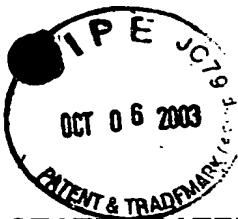


Docket No. 3008-0034
File No. 521.41463X00
Client No. PHCF-01103



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Fumihito OKA :
Application S/N: 09/925,626 : Group Art Unit: 2811
Filed: August 10, 2001 : Examiner: S. Hu

For: CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE, CRYSTALLINE SILICON THIN FILM PHOTOVOLTAIC DEVICE, AND PROCESS FOR PRODUCING CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 6, 2003

Sir:

In the matter of the above-identified application, applicants hereby respectfully petition for an extension of time to permit filing a response within the first month subsequent to expiration of the shortened statutory period set in the outstanding Office Action mailed June 4, 2003. A Credit Card Payment Form in the amount of \$110.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135

(Case No. 521.41463X00).

10/08/2003 DTESEM1 00000078 09925626

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Respectfully submitted,

ANTONELLI, TERRY STOUT & KRAUS, LLP

Alfred A. Stadnicki
Registration No. 30,226

AAS/slk